



PATENT
Attorney Docket No. APE-001
(6922/3)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Soucy et al. CONFIRMATION NO: 2518
SERIAL NO.: 09/897,820 GROUP NO.: 3652
FILING DATE: June 29, 2001 EXAMINER: S. Bratlie
TITLE: Apparatus and Methods for Semiconductor Wafer Processing
Equipment

Commissioner for Patents
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AMENDMENT and RESPONSE

This paper is submitted in response to an Office action, Paper No. 10, mailed from the U.S. Patent and Trademark Office on October 14, 2003.

Applicants respectfully request entry of the following amendments, reconsideration and withdrawal of all grounds of rejection and objection, and passage of the claims to allowance.

Please amend the above-identified application, without prejudice, as follows:

- Amendments to the Claims are reflected in the Listing of Claims, which begins on page 2 of this Amendment and Response.
- Remarks/Arguments begin on page 5 of this Amendment and Response.